

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jong Jin Park et al.

Application No.: 10/786,592

Filing Date: February 26, 2004

Title: METHOD OF MAKING CARBON NANOTUBE PATTERNED FILM OR CARBON NANOTUBE COMPOSITION USING CARBON NANOTUBES SURFACE-MODIFIED WITH POLYMERIZABLE MOIETIES

Group Art Unit: 1756

Examiner: Unassigned

Confirmation No.: 4344

SUBMISSION OF CERTIFIED COPY OF PRIORITY DOCUMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following priority foreign application(s) in the following foreign country is hereby requested, and the right of priority provided in 35 U.S.C. § 119 is hereby claimed.

Country: Republic of Korea

Patent Application No(s): 10-203-0011898

Filed: February 26, 2003

In support of this claim, enclosed is a certified copy(ies) of said foreign application(s). Said prior foreign application(s) is referred to in the oath or declaration and/or the Application Data Sheet. Acknowledgment of receipt of the certified copy(ies) is requested.


Respectfully submitted,

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